Series V74

RECTANGULAR GATE VALVE

PRESYS
PREMIUM SYSTEM

STANDARD TYPE



Application

_Plasma Etch, CVD, Sputter Deposition
_Manufacturing of solar panels
_Semiconductor processing
_All other cluster vacuum systems

Features

_Semi standard application(Semi E21–94, Semi E24–92, Semi–E21.1–1296)
_Patented L–motion link and dual shifts without springs in the actuator enable faster, smoother actuation with signifi–cantly reduced vibration
_Dust seal on the vacuum side of the bonnet flange that virtually eliminates particulate from entering the bellows
_Mechanical locking so at the end of gate travel the valve locks into position
_Welded bellows actuator seal
_Single pneumatic actuator
_Bonnet flange bolts are designed with retainers to eliminate bolts from falling out upon disassembly

Options

_Custom sizes available
_Various o–ring compounds (Kalrez®, Chemraz®, etc.)

www.presys.kr

PREMIUM SYSTEM PRESYS

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